

EAST Search History

Ref #	Hits	Search Query	DBs	Default Operator	Plurals	Time Stamp
S1	0	((pattern with correct\$3 with mask with semiconductor) and (variable same correct\$3 same line same width same overlap\$4 same grid same misalignment)).clm.	US-PGPUB; USPAT; USOCR; FPRS; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2007/09/17 17:12
S2	0	((pattern with correct\$3 with mask with semiconductor) and (variable same correct\$3 same line same width same overlap\$4 same misalignment)).clm.	US-PGPUB; USPAT; USOCR; FPRS; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2007/09/17 17:11
S3	0	((variable same correct\$3 same line same width same overlap\$4 same misalignment)).clm.	US-PGPUB; USPAT; USOCR; FPRS; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2007/09/17 17:11
S4	0	((variable same line same width same overlap\$4 same misalignment)).clm.	US-PGPUB; USPAT; USOCR; FPRS; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2007/09/17 17:11
S5	0	((pattern with correct\$3 with mask with semiconductor) and (line same width same overlap\$4)).clm.	US-PGPUB; USPAT; USOCR; FPRS; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2007/09/17 17:21
S6	24296	382/144,145,147.ccls. 438/16,401,462,800.ccls. 716/2,19,20,21.ccls. 356/237.4,237.5,394.ccls. 430/4,5,30.ccls. 700/96,97,105,120,121.ccls.	US-PGPUB; USPAT; USOCR; FPRS; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2007/09/18 11:58
S7	373	((pattern with mask) and ((correct\$3 or fix\$3 or chang\$3 or adjust\$3) same line same width same overlap\$4))	US-PGPUB; USPAT; USOCR; FPRS; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2007/09/17 17:31

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S8	82	S6 and S7	US-PGPUB; USPAT; USOCR; FPRS; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2007/09/17 17:27
S9	4484	((semiconductor or wafer or mask or IC) and ((correct\$3 or fix\$3 or chang\$3 or adjust\$3) same line same width same overlap\$4))	US-PGPUB; USPAT; USOCR; FPRS; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2007/09/17 17:33
S10	100	S6 and S9	US-PGPUB; USPAT; USOCR; FPRS; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2007/09/17 17:31
S11	119	((semiconductor or wafer or mask or IC) and ((correct\$3 or fix\$3 or chang\$3 or adjust\$3) same line same width same overlap\$4 same (misalign\$3 or askew or skew\$3 or uneven or asymmetric\$3)))	US-PGPUB; USPAT; USOCR; FPRS; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2007/09/17 17:35
S12	4	S6 and S11	US-PGPUB; USPAT; USOCR; FPRS; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2007/09/17 17:35
S13	7	((pattern with mask) and ((correct\$3 or fix\$3 or chang\$3 or adjust\$3) same line same width same overlap\$4 same (misalign\$3 or askew or skew\$3 or uneven or asymmetric\$3)))	US-PGPUB; USPAT; USOCR; FPRS; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2007/09/17 17:36
S14	12	((pattern with mask) and ((correct\$3 or fix\$3 or chang\$3 or adjust\$3) same width same overlap\$4 same (misalign\$3 or askew or skew\$3 or uneven or asymmetric\$3)))	US-PGPUB; USPAT; USOCR; FPRS; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2007/09/17 17:35

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S15	35	((pattern with mask) and ((correct\$3 or fix\$3 or chang\$3 or adjust\$3) same line same width same (overlap\$4 or join\$3 or connect\$3 or overlay\$3 or intersect\$3) same (misalign\$3 or askew or skew\$3 or uneven or asymmetric\$3)))	US-PGPUB; USPAT; USOCR; FPRS; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2007/09/17 17:37
S16	774	((semiconductor or wafer or mask or IC) and ((correct\$3 or fix\$3 or chang\$3 or adjust\$3) same line same width same (overlap\$4 or join\$3 or connect\$3 or overlay\$3 or intersect\$3) same (misalign\$3 or askew or skew\$3 or uneven or asymmetric\$3)))	US-PGPUB; USPAT; USOCR; FPRS; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2007/09/17 17:38
S17	8	S6 and S16	US-PGPUB; USPAT; USOCR; FPRS; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2007/09/17 17:38

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- #2 (((semiconductor or wafer or mask or ic) and ((correct* or fix* or chang* or adjust*) <paragraph> line <paragraph> width <paragraph> overlap*)))<in>metadata)
- #3 (((semiconductor or wafer or mask or ic) and ((correct* or fix* or chang* or adjust*) <paragraph> line <paragraph> width <paragraph> (overlap* or join* or connect* or overlay* or intersect*) <paragraph> (misalign* or askew or skew* or uneven or asymmetric*)))<in>metadata)

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IET JNL IET Journal or Magazine

IEEE CNF IEEE Conference Proceeding

IET CNF IET Conference Proceeding

IEEE STD IEEE Standard

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- ☐ 1. Driving spectral resolution to the noise limit in semiconductor gamma de Lachish, U.;
[Nuclear Science, IEEE Transactions on](#)
 Volume 48, Issue 3, Part 1, June 2001 Page(s):520 - 523
 Digital Object Identifier 10.1109/23.940110
[AbstractPlus](#) | [References](#) | Full Text: [PDF\(76 KB\)](#) IEEE JNL
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- ☐ 2. Driving spectral resolution to the noise limit in semiconductor gamma de Lachish, U.;
[Nuclear Science Symposium Conference Record, 2000 IEEE](#)
 Volume 2, 15-20 Oct. 2000 Page(s):9/175 - 9/178 vol.2
 Digital Object Identifier 10.1109/NSSMIC.2000.949893
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Inventor Name Search Result

Your Search was:

Last Name = HASHIMOTO

First Name = KOJI

Application#	Patent#	Status	Date Filed	Title	Inventor Name
<u>06724592</u>	Not Issued	161	04/18/1985	METHODS FOR PREPARATION OF OVERLAID METAL LAYERS	HASHIMOTO, KOJI
<u>06837812</u>	Not Issued	166	03/10/1986	HIGHLY CORROSION-RESISTANT AND HIGH STRENGTH ALUMINUM ALLOYS	HASHIMOTO, KOJI
<u>06838651</u>	Not Issued	166	03/11/1986	HIGHLY CORROSION-RESISTANT AMORPHOUS ALLOY	HASHIMOTO, KOJI
<u>06844902</u>	Not Issued	166	03/27/1986	HIGHLY CORROSION-RESISTANT AMORPHOUS ALLOY	HASHIMOTO, KOJI
<u>06861371</u>	<u>4772773</u>	150	02/18/1986	METHODS FOR PREPARATION OF OVERLAID AMORPHOUS ALLOY LAYERS	HASHIMOTO, KOJI
<u>06892827</u>	<u>4770949</u>	150	08/04/1986	SURFACE ACTIVATED AMORPHOUS AND SUPERSATURATED SOLID SOLUTION ALLOYS FOR ELECTRODES IN THE ELECTROLYSIS OF SOLUTIONS AND THE METHOD FOR THEIR SURFACE ACTIVATION	HASHIMOTO, KOJI
<u>07098387</u>	Not Issued	166	09/18/1987	SURFACE ACTIVATED SURFACE ALLOY ELECTRODES AND A PROCESS FOR PREPARING THEM	HASHIMOTO, KOJI
<u>07098391</u>	<u>4834806</u>	150	09/18/1987	CORROSION-RESISTANTSTROCTURE STRUCTURE COMPRISING A METALLK SURFACE AND AN SURFACE BONDED THEREEUPON	HASHIMOTO, KOJI

<u>07099371</u>	<u>4743314</u>	150	09/21/1987	HIGHLY CORROSION-RESISTANT AMORPHOUS ALLOY OF NI-CU-TI WITH TA AND/OR NB	HASHIMOTO, KOJI
<u>07162987</u>	<u>4877574</u>	150	03/02/1988	METHOD OF AND APPARATUS FOR CONTROLLING POWER OF NATURAL CIRCULATION REACTOR	HASHIMOTO, KOJI
<u>07183553</u>	<u>4880482</u>	250	04/19/1988	HIGHLY CORROSION-RESISTANT AMORPHOUS ALLOY	HASHIMOTO, KOJI
<u>07183981</u>	Not Issued	166	04/20/1988	AMORPHOUS ALUMINUM ALLOYS	HASHIMOTO, KOJI
<u>07195732</u>	<u>4868073</u>	150	05/16/1988	HIGHLY ACTIVE CATALYST AND HIGHLY ACTIVE ELECTRODE MADE OF THIS CATALYST	HASHIMOTO, KOJI
<u>07236262</u>	Not Issued	161	08/23/1988	HIGHLY CORROSION-RESISTANT AND HIGH-STRENGTH ALUMINUM ALLOYS	HASHIMOTO, KOJI
<u>07275642</u>	<u>4968363</u>	250	11/22/1988	METHOD OF PREVENTING CORROSION OF A MATERIAL AGAINST HYDROCHLORIC ACID	HASHIMOTO, KOJI
<u>07306264</u>	Not Issued	166	02/01/1989	HIGHLY CORROSION-RESISTANT AMORPHOUS ALLOY	HASHIMOTO, KOJI
<u>07339611</u>	Not Issued	166	02/24/1989	AMORPHOUS ALLOY HAVING HIGH CORROSION RESISTANCE	HASHIMOTO, KOJI
<u>07420903</u>	<u>5015352</u>	150	10/13/1989	PREPARATION METHOD FOR AMORPHOUS SUPERLATTICE ALLOYS	HASHIMOTO, KOJI
<u>07420930</u>	<u>5076865</u>	250	10/13/1989	AMORPHOUS ALUMINUM ALLOYS	HASHIMOTO, KOJI
<u>07440592</u>	<u>5087401</u>	150	11/22/1989	PROCESS FOR PREPARING POLYESTER FILAMENTARY MATERIAL	HASHIMOTO, KOJI
<u>07453966</u>	Not Issued	161	12/20/1989	SURFACE ACTIVATED SURFACE ALLOY ELECTRODES AND A PROCESS FOR PREPARING THEM	HASHIMOTO, KOJI
<u>07454412</u>	<u>5030300</u>	250	12/21/1989	AMORPHOUS ALUMINUM ALLOYS	HASHIMOTO, KOJI

<u>07481718</u>	<u>4964967</u>	150	02/16/1990	SURFACE ACTIVATED ALLOY ELECTRODES AND PROCESS FOR PREPARING THEM	HASHIMOTO, KOJI
<u>07529727</u>	Not Issued	161	05/23/1990	STABILIZED SPORE-FORMING VIABLE MICROORGANISMS PREPARATION, ITS PRODUCTION AND PELLET THEREOF	HASHIMOTO, KOJI
<u>07592368</u>	<u>5123980</u>	150	10/03/1990	SPUTTER DEPOSITED AMORPHOUS TITANIUM ALUMIUN ALLOYS	HASHIMOTO, KOJI
<u>07593745</u>	<u>5041175</u>	150	10/05/1990	AMORPHOUS ALUMINUM ALLOYS	HASHIMOTO, KOJI
<u>07662283</u>	Not Issued	161	02/28/1991	AMORPHOUS ALLOY CATALYSTS FOR CONVERSION OF CARBON DIOXIDE	HASHIMOTO, KOJI
<u>07662286</u>	Not Issued	161	02/28/1991	AMORPHOUS ALLOY CATALYSTS FOR DECOMPOSITION OF FLONS	HASHIMOTO, KOJI
<u>07758851</u>	Not Issued	161	09/12/1991	CATALYST MATERIAL AND METHOD FOR DECOMPOSITION OF CHLOROFLUOROCARBONS	HASHIMOTO, KOJI
<u>07766064</u>	Not Issued	166	09/27/1991	GENE DETECTION METHOD	HASHIMOTO, KOJI
<u>07779985</u>	Not Issued	166	10/21/1991	AMORPHOUS ALUMINUM ALLOYS	HASHIMOTO, KOJI
<u>07830847</u>	<u>5264498</u>	250	02/04/1992	POLYCARBONATE RESIN COMPOSITION	HASHIMOTO, KOJI
<u>07853436</u>	<u>5468576</u>	150	03/18/1992	METHOD FOR MANUFACTURING EXPOSURE MASK AND THE EXPOSURE MASK	HASHIMOTO, KOJI
<u>07856159</u>	<u>5326736</u>	250	04/01/1992	AMORPHOUS ALLOY CATALYSTS FOR CONVERSION OF EXHAUST GASES TO HARMLESS GASES	HASHIMOTO, KOJI
<u>07867127</u>	<u>5245112</u>	250	04/10/1992	METHOD FOR DECOMPOSITION OF CHLOROFLUORCARBONS	HASHIMOTO, KOJI
<u>07867527</u>	<u>5283059</u>	150	04/13/1992	PROCESS FOR PRODUCING A STABILIZED STORE-FORMING VIABLE MICROORGANISMS PREPARATION CONTAINING BACILUS CEREUS	HASHIMOTO, KOJI

<u>07869629</u>	5220108	250	04/16/1992	AMORPHOUS ALLOY CATALYSTS FOR DECOMPOSITION OF FLONS	HASHIMOTO, KOJI
<u>07878567</u>	Not Issued	166	05/05/1992	HIGH CORROSION-RESISTANT AMORPHOUS ALLOYS	HASHIMOTO, KOJI
<u>07880047</u>	5217332	150	05/07/1992	DRILL BIT FOR ADVANCED MATERIALS	HASHIMOTO, KOJI
<u>07892477</u>	Not Issued	161	06/02/1992	HIGHLY CORROSION- RESISTANT AMORPHOUS ALLOY	HASHIMOTO, KOJI
<u>07913421</u>	5248754	150	07/15/1992	PROCESS FOR CONTINUOUS PRODUCTION OF POLYCARBONATE OLIGOMER	HASHIMOTO, KOJI
<u>07914027</u>	5634989	150	07/15/1992	AMORPHOUS NICKEL ALLOY HAVING HIGH CORROSION RESISTANCE	HASHIMOTO, KOJI
<u>07955256</u>	5319324	150	10/01/1992	METHOD OF DIRECT BONDING OF CRYSTALS AND CRYSTAL DEVICES	HASHIMOTO, KOJI
<u>07961783</u>	Not Issued	166	10/15/1992	HIGH CORROSION RESISTANT AMORPHOUS ALLOYS	HASHIMOTO, KOJI
<u>08007577</u>	Not Issued	163	01/22/1993	HIGHLY CORROSION RESISTANT AMORPHOUS ALUMINUM ALLOY	HASHIMOTO, KOJI
<u>08008758</u>	Not Issued	163	01/25/1993	HIGHLY CORROSION RESISTANT AMORPHOUS ALUMINUM ALLOY	HASHIMOTO, KOJI
<u>08009397</u>	Not Issued	161	01/27/1993	AMORPHOUS ALUMINUM ALLOYS	HASHIMOTO, KOJI
<u>08041427</u>	5364711	150	03/31/1993	FUEL CELL	HASHIMOTO, KOJI
<u>08044534</u>	Not Issued	166	04/07/1993	AMORPHOUS ALLOYS RESISTANT AGAINST HOT CORROSION	HASHIMOTO, KOJI
<u>08073623</u>	Not Issued	166	06/07/1993	HIGH CORROSION-RESISTANT AMORPHOUS ALLOYS	HASHIMOTO, KOJI

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Inventor Name Search Result

Your Search was:

Last Name = USUI

First Name = SATOSHI

Application#	Patent#	Status	Date Filed	Title	Inventor Name
<u>06945298</u>	<u>4746536</u>	150	12/17/1986	METHOD FOR SELECTIVE CHEMICAL PLATING	USUI, SATOSHI
<u>07987593</u>	<u>5328541</u>	250	12/09/1992	METHOD OF WELDING TUBULAR PRODUCTS OF POLYARYLENE SULFIDE AND WELDED TUBULAR STRUCTURE	USUI, SATOSHI
<u>08364693</u>	Not Issued	161	12/28/1994	APPARATUS AND METHOD FOR WELDING THERMOPLASTIC RESIN MEMBERS	USUI, SATOSHI
<u>08365285</u>	Not Issued	161	12/28/1994	METHOD FOR WELDING TUBULAR MEMBERS	USUI, SATOSHI
<u>08370485</u>	Not Issued	161	01/09/1995	APPARATUS AND METHOD FOR WELDING TUBULAR MEMBERS	USUI, SATOSHI
<u>09137684</u>	<u>6136478</u>	150	08/21/1998	MASK PATTERN CORRECTION METHOD AND EXPOSURE MASK TO BE USED FOR SUCH A METHOD	USUI, SATOSHI
<u>09155546</u>	Not Issued	164	09/25/1998	RESIN COMPOSITION	USUI, SATOSHI
<u>09650672</u>	<u>6526250</u>	150	08/30/2000	TRANSFER FIXING DEVICE, IMAGE BEARING AND CONVEYING BODY, AND IMAGE FORMING APPARATUS	USUI, SATOSHI
<u>09662219</u>	Not Issued	71	09/14/2000	Pattern correcting method of mask for manufacturing a semiconductor device and recording medium having recorded its pattern correcting method	USUI, SATOSHI
<u>09815004</u>	<u>6727026</u>	150	03/23/2001	SEMICONDUCTOR	USUI, SATOSHI

				INTEGRATED CIRCUIT PATTERNS	
<u>09985810</u>	<u>6617083</u>	150	11/06/2001	METHOD OF CORRECTING MASK PATTERNS	USUI, SATOSHI
<u>10084386</u>	Not Issued	164	02/28/2002	HIGH PRESSURE FUEL PUMP FOR INTERNAL COMBUSTION ENGINE	USUI, SATOSHI
<u>10127770</u>	<u>6622296</u>	150	04/23/2002	EXPOSURE MASK PATTERN CORRECTION METHOD, PATTERN FORMATION METHOD, AND A PROGRAM PRODUCT FOR OPERATING A COMPUTER	USUI, SATOSHI
<u>10274034</u>	<u>7165534</u>	150	10/21/2002	FUEL FEED SYSTEM	USUI, SATOSHI
<u>10442203</u>	<u>7152583</u>	150	05/21/2003	HIGH-PRESSURE FUEL PUMP	USUI, SATOSHI
<u>10614206</u>	Not Issued	161	07/08/2003	HIGH PRESSURE FUEL PUMP FOR INTERNAL COMBUSTION ENGINE	USUI, SATOSHI
<u>10896039</u>	<u>7124738</u>	150	07/22/2004	DAMPER MECHANISM AND HIGH PRESSURE FUEL PUMP	USUI, SATOSHI
<u>10975001</u>	Not Issued	30	10/28/2004	Image information processing system, image information processing apparatus, image information outputting method, code information processing apparatus and program thereof	USUI, SATOSHI
<u>10975412</u>	Not Issued	30	10/29/2004	Image outputting system, image processing apparatus, image processing method and program thereof	USUI, SATOSHI
<u>11217444</u>	Not Issued	61	09/02/2005	Controlling apparatus of variable capacity type fuel pump and fuel supply system	USUI, SATOSHI
<u>11219674</u>	Not Issued	30	09/07/2005	Index sheet, picture case, image processing apparatus, image processing method and storage medium storing program	USUI, SATOSHI
<u>11354851</u>	Not Issued	61	02/16/2006	Electromagnetic drive mechanism and a high-pressure fuel supply pump	USUI, SATOSHI
<u>11409062</u>	Not Issued	20	04/24/2006	High pressure fuel pump for internal combustion engine	USUI, SATOSHI
<u>11546430</u>	Not	41	10/12/2006	Damper mechanism and high	USUI, SATOSHI

	Issued			pressure fuel pump	
11582396	Not Issued	41	10/18/2006	High-pressure fuel supply system using variable displacement fuel pump	USUI, SATOSHI
11599468	Not Issued	25	11/15/2006	High-pressure fuel pump	USUI, SATOSHI
11622170	Not Issued	41	01/11/2007	High pressure fuel pump provided with damper	USUI, SATOSHI
11780940	Not Issued	17	07/20/2007	High-Pressure Fuel Pump	USUI, SATOSHI
11835544	Not Issued	19	08/08/2007	High-Pressure Fuel Supply Pump	USUI, SATOSHI

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Inventor Name Search Result

Your Search was:

Last Name = YOSHIKAWA

First Name = KEI

Application#	Patent#	Status	Date Filed	Title	Inventor Name
<u>09662219</u>	Not Issued	71	09/14/2000	Pattern correcting method of mask for manufacturing a semiconductor device and recording medium having recorded its pattern correcting method	YOSHIKAWA, KEI
<u>10107298</u>	<u>7208423</u>	150	03/28/2002	SEMICONDUCTOR DEVICE FABRICATION METHOD AND SEMICONDUCTOR DEVICE	YOSHIKAWA, KEI
<u>11643907</u>	Not Issued	30	12/22/2006	Semiconductor device fabrication method and semiconductor device	YOSHIKAWA, KEI
<u>07470028</u>	Not Issued	166	01/25/1990	AQUEOUS RESIN COMPOSITION	YOSHIKAWA, KEIGO
<u>07884882</u>	Not Issued	161	05/18/1992	AQUEOUS RESIN COMPOSITION	YOSHIKAWA, KEIGO
<u>06592588</u>	<u>4566163</u>	150	03/23/1984	AUTOMATIC SUPERVISORY SYSTEM FOR A WARPER	YOSHIKAWA, KEIJI
<u>07823364</u>	<u>5242224</u>	150	01/21/1992	TEMPERATURE MONITORING UNIT	YOSHIKAWA, KEIJI
<u>09763130</u>	<u>6452056</u>	250	02/20/2001	PROCESS FOR THE PREPARATION OF FLUOROBENZYL DERIVATIVES	YOSHIKAWA, KEISUKE
<u>09897077</u>	<u>6756793</u>	150	07/03/2001	CAPACITANCE TYPE MOISTURE SENSOR AND METHOD OF PRODUCING THE SAME	YOSHIKAWA, KEISUKE
<u>10781947</u>	<u>7064011</u>	150	02/20/2004	SEMICONDUCTOR DEVICE FABRICATING APPARATUS AND SEMICONDUCTOR DEVICE FABRICATING	YOSHIKAWA, KEISUKE

				METHOD	
<u>11000905</u>	<u>7268191</u>	150	12/02/2004	METHOD FOR PRODUCING EPOXY RESIN COMPOSITION FOR SEMICONDUCTOR ENCAPSULATION AND EPOXY RESIN COMPOSITION FOR SEMICONDUCTOR ENCAPSULATION AND SEMICONDUCTOR DEVICE OBTAINED THEREBY	YOSHIKAWA, KEISUKE
<u>11012126</u>	<u>7132755</u>	150	12/16/2004	ADHESIVE FILM FOR MANUFACTURING SEMICONDUCTOR DEVICE	YOSHIKAWA, KEISUKE
<u>11115307</u>	<u>7262514</u>	150	04/27/2005	EPOXY RESIN COMPOSITION FOR SEMICONDUCTOR ENCAPSULATION, SEMICONDUCTOR DEVICE USING THE SAME, AND PROCESS FOR PRODUCING SEMICONDUCTOR DEVICE	YOSHIKAWA, KEISUKE
<u>11362783</u>	Not Issued	61	02/28/2006	Semiconductor device fabricating apparatus and semiconductor device fabricating method	YOSHIKAWA, KEISUKE
<u>11632348</u>	Not Issued	30	03/05/2007	Semiconductor Device, Substrate for Producing Semiconductor Device and Method of Producing Them	YOSHIKAWA, KEISUKE
<u>09117599</u>	<u>6155380</u>	150	07/31/1998	GREASE FILLING DEVICE FOR ELECTRIC MOTOR	YOSHIKAWA, KEIZO
<u>09117600</u>	Not Issued	161	07/31/1998	BEARING CLEANING DEVICE FOR ELECTRIC MOTOR	YOSHIKAWA, KEIZO

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